

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen et al. Docket No.: QIM 2004 SP 00115 US
Serial No.: 10/721,225 Art Unit: 1792
Filed: November 26, 2003 Examiner: Tran, Binh X.
Conf. No.: 5694
For: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed July 30, 2009. Please amend the above-referenced application as follows.